

Radioisotope Thin-Film Powered Microsystems

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Rajesh Duggirala • Amit Lal
Shankar Radhakrishnan

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Rajesh Duggirala
Intel Corporation
Hillsboro, OR, USA
rajesh.duggi@gmail.com

Amit Lal
Cornell University
School of Electrical and Computer
Engineering
Ithaca, NY, USA
lal@ece.cornell.edu

Shankar Radhakrishnan
Cornell University
New York, NY, USA
shankarrad@gmail.com

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To my grandparents
Ammamma and Tatagaru
and my parents
Usha Rani and Vijaya Sekhar Duggirala

Rajesh

I am thankful to my family and grateful to my friends. I am
thankful and grateful to my wife for being both.

Shankar

Preface

This book presents the technical accomplishments of research that started with the intent of realizing radioisotope micro-power sources suitable for microelectromechanical systems, and subsequently broadened into exploring other micro-scale applications of the unique properties of radioactivity. The text primarily discusses the radioisotope powered electromechanical micro power generators developed as part of the research, and their applications in long lifetime wireless sensors. These electromechanical micro power generators utilize very low quantities of radioisotope fuels, to minimize radiation hazard and safety concerns, and use high efficiency pulsed release of energy to amplify the low power output of low activity radioisotopes by 10^3 – 10^5 to power microsystems. The text also introduces other micro-scale applications of radioactivity by presenting radioactivity based counting clocks. The success in the demonstration of the above two applications have encouraged us in the SonicMEMS Laboratory at Cornell University to successfully explore new and exciting micro-scale applications of radioisotopes such as massively parallel nano-scale lithography, self-powered lamps, and self-powered ultra-high vacuum pumps and gauges.

This research started in year 2000 when we were investigating micro power generators suitable for long lifetime microsystems including wireless sensor networks. Reliable, compact, and long lifetime micro power sources are needed to successfully deploy wireless sensor networks for applications ranging from environmental monitoring to national security. Our investigations revealed that there were no commercial or even research stage micro power sources available that could satisfy the requirements of the wireless sensor networks. We identified that the main limitation of the available micro power sources was the low energy density of fuels being used, and started exploring the use of high energy density radioisotope fuels to micro power sources. Radioisotope fuels also have the advantage of being very reliable under a wide range of environmental conditions, as the rate of isotope disintegration does not change with ambient conditions. Initially guided by our nuclear engineering colleagues at University of Wisconsin-

Madison, we embarked on this exciting area of research, and to our surprise and delight, discovered new and exciting phenomenon in electrostatics, vacuum science, surface science, and materials science, that led to the research and development of novel applications of radioisotopes at the micro scale.

While we are successfully solving the technological problems currently limiting microsystems by applying the unique properties of radioisotopes, we are aware that the biggest hurdle to the widespread adoption of radioisotope technologies is the perception that radioisotopes are unsafe and should be avoided as much as possible. This is both because of a lack of general knowledge about radioisotopes, and a lack of awareness among the public about the widespread use of radioisotopes around us. In spite of radioisotopes and their applications ranging from nuclear power to nuclear arms playing an important role in all our lives, even engineering students rarely get exposed and educated in the basics of radioactivity. The physics and health-physics of radioisotopes are only taught on a need-to-know basis to people experimenting with radioisotopes in medical and biological sciences. The science and technology of producing and handling radioisotopes is even more elusive, due to the small number of companies that produce radioisotopes commercially. This lack of knowledge prevents a rational cost benefit analysis for every radioisotope application, as was done in the past, where several radioisotope based commercial devices were approved by the Nuclear Regulatory Commission and Food and Drug Administration, including:

1. Tritium powered light sources: These include self-powered exit signs, and watches. These sources use tritium with activities in the range from microCuries to 10–20 Curies. These light sources are regulated by the Nuclear Regulatory Commission and have been approved for use even in elementary schools and airplanes, where highly reliable function is needed to potentially save lives.
2. Gas ionizers: Nickel-63 is used in airport gas detectors to ionize the gas atoms, effusing off the wipes that are used to collect samples from luggage. Although other technologies for gas ionization are possible, the ultimate reliability and

decreased chances of false-negatives in testing provide the justification for the use of radioisotopes to potentially save lives.

3. Smoke detectors: Americium-241 (10 microCurie) is used in smoke detectors for its alpha radiation, which is directed toward an alpha particle detector placed across an air chamber. When smoke enters the air chamber, the smoke particles stop the alpha particles from the crossing the air chamber and being incident on the detector. The lack of alpha particle radiation at the detectors serves as a smoke signal. The stability of alpha particle emission by Americium-241, compared to other ion-emission technologies, enables a highly reliable smoke detector that can save lives.
4. Radioisotope power sources on space missions: NASA uses radioisotope sources (based on plutonium alpha emission), that provide power for several years to tens of years required for mission. Here, no other source would provide the reliability needed for such missions.
5. Radioisotopes in Medicine: Radioisotopes are used everyday in various medical procedures to save lives. These procedures include Positron Emission Tomography (PET) and radiation therapies for many types of cancer. In PET therapy, the specific positron generated by radioisotopes is detected by the resulting gamma particles. In cancer therapy, neutron–boron reaction is used to cause local damage to tissue. Additionally, radioisotopes are used in the discovery of biological phenomena. In many biological labs, radioisotope labeling is used to trace proteins and DNA by size and mass on X-ray film.

In all of the above cases, a risk-benefit analysis led to the commercial acceptance of the devices, because these devices were reliable, and had the potential to save lives. In the case of microsystems such as sensor networks, we face the same choice. Can we develop a technology that might provide high reliability and operation in harsh environments, such that the true benefit of sensor networks to mankind can be achieved? We answer this in the affirmative, with the material in this text. We also introduce

the basics of the physics and the health physics of spontaneous disintegration, so the public can make a rational risk-benefit assessment of all the new applications.

We hope that this new area of radioisotope based micro-power sources and this text book will excite educators, policy makers, environmentalists, and the public at large to appreciate radioisotopes and their various applications that might make our lives safer in the future.

USA
USA
USA

R. Duggirala
A. Lal
S. Radhakrishnan

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We would greatly like to thank the tax-payers of the United States of America and the program managers at DOE and DARPA who funded this work. Without their support, this idea would have remained an interesting curiosity.

We would also to thank the team of Nuclear Engineers at University of Wisconsin-Madison, Prof. Michael Corradini, Prof. James Blanchard, and Prof. Douglas Henderson, who had the courage to support a MEMS group to start radioisotope based microsystem research. We would also like to thank Dr. Madan Dubey and Dr. Ron Polcawich who supported the fabrication of micro fabricated devices at the Army Research Labs. Numerous industrial engineers at Isotope Products Labs and NRD helped in realizing how much we needed to rediscover about radioisotope thin films.

The material presented in this book is a culmination of work and intellectual contributions from several current and previous students of the SonicMEMS Laboratory, including Dr. Hui Li, Prof. Hang Guo, Dr. Norimasa Yoshimizu, Dr. Shyi-Herng Kan, Steven Tin, and Yuerui Liu, in addition to the authors of this book.

TABLE OF CONTENTS

List of Figures	xix
List of Tables	xxxiii
1 Radioactivity and Radioisotopes	1
1.1 Introduction	1
1.2 Radioactive Decay	1
1.3 Radioactive Decay Law	2
1.4 Types of Radioactive Decay	3
1.5 Interaction of Ionizing Radiation with Matter . .	6
1.6 Radiation Safety	9
1.7 Availability of Radioisotopes	11
1.7.1 Tritium	11
1.7.2 Nickel-63	11
1.7.3 Promethium-147	12
2 Radioisotope Thin Films for Microsystems	13
2.1 Introduction	13
2.2 Radioisotope Micropower Generation	13
2.2.1 Radioisotope Thin Film Fuels	14
2.2.2 Power Density, Energy Density, and Lifetime of Radioisotope Fuels	14
2.2.3 Review of Radioisotope Micropower Generation	16
2.2.4 ^{63}Ni Micropower Generation	21
2.2.5 ^{147}Pm Micropower Generation	29
2.3 Radioisotope Direct Charged Voltage Biases for Autonomous Sensors	32
2.3.1 ^{63}Ni Thin Film Generated Voltage Bias for Self-powered Sensors	32
2.4 Radioisotope Decay Rate based Counting Clock .	33

3 Radioisotope Micropower Generation: Microfabricated Reciprocating Electro-Mechanical Power Generators 35

3.1 Introduction 35

3.2 Design 35

 3.2.1 Radioisotope-Charged Electrostatic Actuation Dynamics 37

 3.2.2 Piezoelectric Power Generation 42

 3.2.3 Energy Conversion Efficiency 44

 3.2.4 Radioisotope Fuel Source Design 45

 3.2.5 Piezoelectric Material Selection 49

3.3 Fabrication 50

3.4 Testing and Results 53

 3.4.1 Radioisotope Actuation Dynamics 57

 3.4.2 Power Generation Characteristics 57

3.5 Discussion 60

 3.5.1 Performance Variation with Vacuum Chamber Pressure 60

 3.5.2 Performance Variation with Radioisotope Specific Activity 62

 3.5.3 Performance Variation with Radioisotope Fuel Fill Factor 63

3.6 Conclusions 63

4 Radioisotope Micropower Generation: Integrated Radioisotope Actuated Electro-Mechanical Power Generators 65

4.1 Introduction 65

4.2 Principle of Operation 67

 4.2.1 Charging Phase: Betavoltaic Power Output 68

 4.2.2 Discharge Phase: Wireless RF Signal Generation 70

 4.2.3 Vibration Phase: Piezoelectric Power Generation 71

 4.2.4 Energy Conversion Efficiency 72

4.3 Fabrication 73

4.4	Testing and Results	76
4.4.1	Betavoltaic Power Generation	78
4.4.2	Wireless RF Pulse Generation	81
4.4.3	IREMPG Energy Conversion Efficiency	85
4.5	Discussion	85
4.5.1	Betavoltaic Power Generation	85
4.6	Conclusions	85
4.7	Future Directions	87
5	Radioisotope Micropower Generation: 3D Silicon Electronvoltaics	89
5.1	Introduction	89
5.2	Betavoltaics	89
5.2.1	Operation	89
5.2.2	Theory	92
5.3	Five Milliwatt per cubic centimeter, five Year Lifetime Microbattery Design	96
5.3.1	Radioisotope Thin Film Design	96
5.3.2	3D Silicon Betavoltaic Design	99
5.4	Fabrication	100
5.5	Testing and Results	102
5.6	Discussion	109
5.7	Conclusions	110
5.8	Future Directions	111
6	Radioisotope Direct Charging: Autonomous Wireless Sensors	113
6.1	Introduction	113
6.2	⁶³ Ni Powered Autonomous Wireless Humidity Sensor	114
6.2.1	⁶³ Ni Actuated Reciprocating Cantilever Wireless Transmitter	114
6.2.2	Humidity Sensitive Polymer Capacitor	119
6.2.3	Autonomous Wireless Humidity Sensor	124
6.3	Conclusions	125
7	Radioisotope Decay Rate Based Counting Clock	127
7.1	Introduction	127
7.2	Background	128

7.3	Simple Radioactive Counting Clocks	129
7.3.1	Radioactive Decay: A Poisson Process	129
7.3.2	Clock Architecture	132
7.3.3	Clock Analysis	133
7.3.4	Simulations	139
7.3.5	Experiments	139
7.3.6	Limitations of Simple RCCs	147
7.4	Stochastic Resonators	149
7.4.1	Introduction	149
7.4.2	Dead-Time-Modified Poisson Process	151
7.4.3	Output Frequency of Dead-Time-Modified Poisson Process	153
7.4.4	Simulations	155
7.4.5	Experimental	159
7.4.6	Limitations of DTM RCC	161
7.5	Other Methods	162
7.6	An Aside: True Random Number Generators	163
7.6.1	Introduction	163
7.6.2	True Random Number Generator TRNG-E	165
7.6.3	True Random Number Generator TRNG-U	167
7.6.4	Conclusions and Future Directions	168
7.7	Conclusions	170
7.8	Future Directions	170
A	Thin Film ^3H Actuated Reciprocating Piezoelectric Unimorph Converters	171
A.1	^3H Actuation	172
A.2	Power Generation Characteristics	173
B	Macro-scale Hand Assembled Radioisotope actuated Electro-Mechanical Power Generator	175
B.1	Assembly	175
B.2	Testing	175

Table of Contents	xvii
C Modeling of Radioisotope Actuated Piezoelectric Unimorph Cantilever Dynamics Using Simulink	181
C.1 MATLAB Input File for Defining Rempg Geometrical and Material Property Parameters	183
D MatLab Codes for Counting clock	185
D.1 Simple Counting Clock	185
D.2 SR Codes	185
Bibliography	189
Index	195

LIST OF FIGURES

2.1	Schematic illustrating the various radioisotope energy conversions, including the newly developed radioisotope electro mechanical power generation presented in this book	16
2.2	Schematic illustrating a radioisotope powered thermoelectric generator	17
2.3	Schematic illustrating a radioisotope direct charging generator	18
2.4	Schematic illustrating a radioisotope powered contact potential difference generator	19
2.5	Schematic illustrating a radioisotope powered electronvoltaic generator	19
2.6	Schematic illustrating a radioisotope powered indirect conversion generator	21
2.7	Schematic illustrating the performance space of the radioisotope powered microbatteries and zero-power sensors developed in this book. The ^{147}Pm –Si betavoltaic microbattery performance is estimated based on the design and performance of realized 3D silicon betavoltaics	23
2.8	Schematic illustrating the power requirements of typical periodically sampling low power wireless sensor microsystems. The axes are not to scale	24
2.9	Schematic of a pulsed electrical power generator that integrates the continuous power output of a radioisotope power generator across a storage capacitor, and uses low duty cycle switching for pulsed discharge of the stored electrical energy across the load	24
2.10	Schematic illustrating the radioisotope actuation of self-reciprocating cantilevers, and the generation of electrical energy when the cantilever is a piezoelectric unimorph	25

2.11	Schematic illustrating IREMPG construction, and snapshot of operation during the charging phase. The ^{63}Ni thin film is charged to voltage V_{gap} , and the β -electrons expend energy qV_{gap} in overcoming the impeding electric field before reaching the collector on the piezoelectric unimorph	27
2.12	Schematic illustrating the power output profile of the IREMPG	28
2.13	Schematic illustrating the generation of wireless RF signals in radioisotope actuated reciprocating dielectric cantilevers, due to (a) build-up of an electric field in the dielectric with charges accumulating on either electrode during the charging phase, and (b) excitation of RF modes in the dielectric waveguide by the displacement current caused by the sudden shorting during discharge .	28
2.14	3D dimetric view schematics of (a) 3D silicon diodes, (b) two interleaved betavoltaic wafers to be stacked, and (c) assembled 3D betavoltaics	31
3.1	Schematic illustrating REMPG construction, and snapshot of operation during the charging phase. The ^{63}Ni thin film is charged to voltage V_{gap} , and the β -electrons expend energy qV_{gap} in overcoming the impeding electric field before reaching the collector on the piezoelectric unimorph. Also illustrated is the charge sharing between the piezoelectric unimorph and the vacuum chamber	36
3.2	Schematic representation of REMPG equivalent 1D electromechanical circuit. Here, Q_{gap} and V_{gap} are the charge and voltage across air-gap g at time t , g_0 is the initial gap, k is the stiffness of the unimorph cantilever, b is the damping coefficient, I_r models the charge current and $R_{l,gap}$ the leakage resistance across the air-gap, and C_{gap} and C_p are the capacitances between the radioisotope thin film and the piezoelectric unimorph cantilever and the vacuum chamber respectively	36

3.3	Schematic illustrating the variation in the equivalent point electrostatic force $F_{gap,eq}$, acting on the piezoelectric unimorph cantilever collector, with gap g , as the distributed electrostatic force $F_{gap,dist}$ changes	39
3.4	Plot of the calculated variation of REMPG (a) air-gap charge Q_{gap} and gap g with time for initial gap $g_0 = 1$ mm, and (b) air-gap voltage V_{gap} with time for various g_0 . REMPG dimensions of $l_{cant} = 10$ mm, $l_{piezo} = 4.5$ mm, $w_{cant} = w_{piezo} = 2$ mm, $t_{cant} = 42.5 \mu\text{m}$, $t_{piezo} = 1 \mu\text{m}$ were used in the simulations	41
3.5	Plot of the calculated variation of stored REMPG electrostatic energy $E_{es,rempg}$ and mechanical energy $E_{me,rempg}$ with time during a reciprocation cycle, for initial gap $g_0 = 1$ mm	42
3.6	Plot illustrating the calculated drop in β -electron kinetic energy E_{rad} with distance traversed in ^{63}Ni for 17.3 keV β -electrons	48
3.7	Plot of the calculated variation of radioisotope thin film emission efficiency $\eta_{^{63}\text{Ni}}$ and power output $P_{^{63}\text{Ni}}$ with thickness $t_{^{63}\text{Ni}}$	49
3.8	Photograph of the frontside and backside of the microfabricated piezoelectric unimorph cantilevers. The piezoelectric unimorph cantilever dimensions are: $l_{cant} = 10$ mm, $l_{piezo} = 4.5$ mm, $w_{cant} = w_{piezo} = 2$ mm, $t_{cant} = 42.5 \mu\text{m}$, $t_{piezo} = 1 \mu\text{m}$. . .	51
3.9	Schematic illustration of REMPG piezoelectric unimorph microfabrication process flow	52
3.10	Photograph of the microfabricated piezoelectric unimorphs packaged on a dual inline package (DIP)	53
3.11	Schematic of the REMPG characterization set-up	54
3.12	Plot of measured AlN REMPG piezoelectric unimorph voltage output $V_{out,uni}$	55
3.13	Plot of measured PZT REMPG piezoelectric unimorph voltage output $V_{out,uni}$	56

3.14	Plot of measured increase in (a) AlN REMPG and (b) PZT REMPG reciprocation period T_{rec} with initial gap g_0 compared to simulated variation of REMPG reciprocation periods with (c) $\rho_{gap} = 2.5 \times 10^{13} \Omega\text{-cm}$ and (d) $\rho_{gap} = \infty$. The REMPGs do not reciprocate for $g_0 > 1.067 \text{ mm}$.	57
3.15	Plot of measured increase in maximum piezoelectric unimorph power output $P_{out,uni,max}$ with initial gap g_0 for both AlN and PZT REMPG . . .	58
3.16	Plot of measured variation in energy conversion efficiency η_{rempg} with initial gap g_0 for both AlN and PZT REMPG	59
3.17	Plot of measured variation in radioisotope energy to electromechanical energy conversion efficiency η_{re-eme} with initial gap g_0 for the AlN REMPG .	59
3.18	Plot of measured variation in electromechanical energy to electrical energy conversion efficiency η_{eme-ee} with initial gap g_0 for both AlN and PZT REMPG. Optimal load impedances of 521 k Ω and 4.4 k Ω were employed for the AlN and PZT REMPGs respectively	60
3.19	Plot of measured variation of AlN REMPG energy conversion efficiency η_{rempg} with piezoelectric unimorph load impedance $R_{l,uni}$	61
3.20	Plot of measured variation in REMPG reciprocation period T_{rec} with pressure for different initial gap g_0	61
3.21	Plot of simulated variation in REMPG reciprocation period T_{rec} with different radioisotope source specific activity SA_r for initial gap $g_0 = 1 \text{ mm}$. .	62
4.1	Plot of calculated β -electron kinetic energy unutilized during a reciprocation cycle of the REMPG. REMPG dimensions of $l_{cant} = 10 \text{ mm}$, $l_{piezo} = 4.5 \text{ mm}$, $w_{cant} = w_{piezo} = 2 \text{ mm}$, $t_{cant} = 42.5 \mu\text{m}$, $t_{piezo} = 1 \mu\text{m}$ were used in the simulations	66

4.2	Schematic illustrating IREMPG construction, and snapshot of operation during the charging phase. The ^{63}Ni thin film is charged to voltage V_{gap} , and the β -electrons expend energy qV_{gap} in overcoming the impeding electric field before reaching the collector on the piezoelectric unimorph. Also illustrated is the charge sharing between the piezoelectric unimorph and the vacuum chamber	67
4.3	Schematic illustrating the IREMPG energy conversion mechanism	68
4.4	Schematic illustrating the 1D electromechanical equivalent representation of the IREMPG. Here, Q_{gap} and V_{gap} are the charge and voltage across air-gap g at time t , g_0 is the initial gap, k is the stiffness of the unimorph cantilever, b is the damping coefficient, I_r models the charge current and $R_{l,gap}$ the leakage resistance across the air-gap, and C_{gap} and C_p are the capacitances between the radioisotope thin film and the piezoelectric unimorph cantilever and the vacuum chamber respectively	69
4.5	Schematic illustrating (a) the accumulation of charge across the dielectric during the charging phase, and (b) the impulse excitation of the thin film dielectric waveguide during air-gap discharge	70
4.6	Schematic illustration of the electrical and magnetic fields generated in the discharge of the IREMPG. The unimorph cantilever is simplified for illustration	71
4.7	Photograph of the frontside and backside of the microfabricated piezoelectric unimorph cantilevers with integrated betavoltaics. The piezoelectric unimorph cantilever dimensions are: $l_{cant} = 10$ mm, $l_{piezo} = 4.5$ mm, $w_{cant} = w_{piezo} = 2$ mm, $t_{cant} = 42.5$ μm , $t_{piezo} = 1$ μm , $l_{\beta} = 4$ mm, and $w_{\beta} = 4$ mm	74
4.8	Schematic illustration of microfabrication process flow for IREMPG piezoelectric unimorphs with integrated betavoltaics	75